Geant4 Electromagnetic Physics Introduction

Editors:

Michel Maire (LAPP, Annecy, France) Vladimir Ivanchenko (CERN & EMSU, Moscow) Sebastien Incerti (CNRS/IN2P3, France) on behalf of the Geant4 Standard EM and Low Energy EM Physics Working groups

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Outline

- Electromagnetic (EM) physics overview
 - Introduction
 - Structure of Geant4 EM sub-packages
 - Processes and models
- Geant4 cuts
 - Cut in range and energy thresholds
- How to invoke EM physics in Geant4
 - EM Physics Lists
 - How to extract physics?

Electromagnetic (EM) physics overview

Geant4 Electromagnetic Physics

- Release with the 1st version of Geant4 with EM physics based on Geant3 experience (1998)
- Significant permanent development in many aspects of EM processes simulation since the beginning up to now
- Many years is used for large HEP experiments
 BaBar, SLAC (since 2000)
 - □ LHC experiments ATLAS, CMS and LHCb (since 2004)
- Many common requirements for HEP, space, medical and other applications
- EM web page (common for Standard and Low-energy working groups):

http://cern.ch/geant4/collaboration/working_groups/electromagnetic/index.shtml

Geant4 simulation of ATLAS experiment at LHC, CERN



Gamma and Electron Transport

• Photon processes:

- γ conversion into e⁺e⁻ pair
- Compton scattering
- Photoelectric effect
- Rayleigh scattering
- Gamma-nuclear interaction in hadronic sub-package CHIPS
- Electron and positron processes:
 - Ionization
 - Coulomb scattering
 - Bremsstrahlung
 - Nuclear interaction in hadronic sub-package CHIPS
- Positron annihilation
- HEP & many other Geant4 applications with electron and gamma beams





Geant4 course - Electromagnetic 1

Geant4 EM packages

- Standard
 - γ, e up to 100 TeV
 - hadrons up to 100 TeV
 - ions up to 100 TeV
- Muons
 - up to 1 PeV
 - Energy loss propagator
- Xrays
 - X-ray and optical photon production processes
- High-energy
 - Processes at high energy (E>10GeV)
 - Physics for exotic particles
- Polarisation
 - Simulation of polarized beams
- Optical
 - Optical photon interactions

- Low-energy
 - Livermore library γ, e- from 10 eV up to 1 GeV
 - Livermore library based polarized processes
 - PENELOPE code rewrite , γ, e- , e+ from 250 eV up to 1 GeV
 - hadrons and ions up to 1 GeV
 - Microdosimetry models (Geant4-DNA project) from 7 eV to 10 MeV
 - Atomic deexcitation
- Adjoint
 - New sub-library for reverse Monte Carlo simulation from the detector of interest back to source of radiation
- Utils general EM interfaces

Software design

- Since Geant4 9.3beta (June, 2009) the design is uniform for all EM packages
 - Allowing a coherent approach for high-energy and low-energy applications
- A physical interaction or process is described by a process class
 - Naming scheme : « G4ProcessName »
 - For example, G4Compton for photon Compton scattering
 - Assigned to Geant4 particle type
 - Inherit from G4VEmProcess base class
- A physical process can be simulated according to several models, each model being described by a <u>model class</u>
 - Naming scheme : « G4ModelNameProcessNameModel »
 - For example, G4LivermoreComptonModel
 - Models can be assigned to certain energy ranges and G4Regions
 - Inherit from G4VEmModel base class
- Model classes provide the computation of
 - Cross section and stopping power
 - Sample selection of atom in compound
 - Final state (kinematics, production of secondaries...)

Example: Muon Energy Loss

- Continuous energy loss
 - Contribution from processes:
 - » Ionization
 - » Bremsstrahlung
 - » Production of e⁺e⁻
- Ionisation and deltaelectron production
 - G4BetheBlochModel
- Below 200 keV ICRU'49 parameterization of dEdx
 - G4BraggIonModel
- Radiative corrections to ionization at E > 1 GeV
 - G4MuBetheBlochModel

Total muon energy loss

$$\frac{dE}{dx} = n \sum_{i} \left(\int_{0}^{T_{cut}} T \frac{d\sigma}{dT} dT \right)$$



Comments

- The list of available processes and models is maintained by EM working groups in EM web pages
- It is shown in Geant4 extended and advanced examples how to use EM processes and models
- User feedback always welcome

Geant4 Cuts

Bremsstrahlung

- Bremsstrahlung spectrum grows to low energy as 1/k (k is the gamma energy)
- Low energy gamma has very small absorption length
- Simulation of all low-energy gamma is non-effective
- Cuts/production threshold are used in all Monte Carlo codes
- Gamma emission below production threshold is taken into account as continues energy loss
- Similar approach is used for ionisation process where spectrum is proportional to 1/T²

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Geant4 Cuts

- No tracking cuts by default
- Unique production threshold definition via RANGE
- For a typical process (G4hlonisation, G4elonisation, ...) production threshold T_c subdivides continues and discrete part of energy loss:
 - Energy loss $\frac{dE}{dx} = n \int_{0}^{T_{c}} t \frac{d\sigma(t)}{dt} dt$
 - δ-electron production

$$\sigma = \int_{T_c}^{T_{\max}} \frac{d\sigma}{dt} dt$$

- By default energy loss is deposited at the step
- Optionally energy loss can be partially used
 - for generation of extra δ -electrons under the threshold when track is in vicinity of a geometry boundary (sub-cutoff)
 - for sampling of fluorescence and Auger–electrons emission

Effect of Production thresholds



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What processes are using cuts?

- Energy thresholds for gamma are used in bremsstrahlung
- Energy thresholds for electrons are used in ionisation and e+e- pair production processes
- Energy threshold for positrons is used in the e+e- pair production process
- Energy thresholds for gamma and electrons are used optionally ("ApplyCuts" options) in all discrete processes
 - Photoelectric effect, Compton, gamma conversion
- Energy threshold for protons are used in processes of elastic scattering of hadrons and ions defining the threshold for kinetic energy of nuclear recoil
 - New feature available since December 2009

Comments

- Range cut approach was established for simulation of energy deposition inside solid or liquid media
 - Sampling and crystal calorimeters
 - Silicon tracking
- For specific user application if may be revised, for example, by defining different cuts in range for electron and gamma
 - Gaseous detectors
 - Muon system
- Tracking cuts may be useful (saving some CPU) for simulation of penetration via shielding or for simulation in non-sensitive part of the apparatus
 - Astrophysics applications

How to invoke EM physics in Geant4?

Physics List

- Physics Lists is the user class making general interface between physics and Geant4 kernel
 - It should include the list of particles
 - The G4ProcessManager of each particle maintains a list of processes
- There are 3 ordered lists of processes per particle which are active at different stage of Geant4 tracking:
 - AtRest (annihilation, ...)
 - AlongStep (ionisation, bremsstrahlung, ...)
 - PostStep (photo-electric, Compton, Cerenkov,....)
- Geant4 provided a set of different configurations of EM physics (G4VPhysicsConstructor) with physics_list library
- These constructors can be included into modular Physics List in user application (G4VModularPhysicsList)

EM Physics Constructors for Geant4 9.3

- G4EmStandardPhysics default
- G4EmStandardPhysics_option1 HEP fast but not precise
- G4EmStandardPhysics_option2 Experimental
- G4EmStandardPhysics_option3 medical, space
- G4EmLivermorePhysics
- G4EmLivermorePolarizedPhysics
- G4EmPenelopePhysics
- G4EmDNAPhysics

Combined Physics Standard > 1 GeV LowEnergy < 1 GeV

- Located at \$G4INSTALL/source/physics_list/builders
- Advantage of using of these classes they are tested on regular base and are used for regular validation

Example - G4EmStandard Physics

Only PostStep

G4ProcessManager* pmanager
If (particleName == "gamma") {
 pmanager->AddDiscreteProcess(new G4PhotoElectricEffect);
 pmanager->AddDiscreteProcess(new G4ComptonScattering);
 pmanager->AddDiscreteProcess(new G4GammaConversion);
} else if (particleName == "e+") {
 pmanager->AddProcess(new G4eMultipleScattering, -1, 1, 1);
 pmanager->AddProcess(new G4eIonisation, -1, 2, 2);
 pmanager->AddProcess(new G4eBremsstrahlung, -1, 3, 3);
 pmanager->AddProcess(new G4eplusAnnihilation, 0, -1, 4);

- Numbers are process order;
 - G4Transportation is the 1st (order = 0) for AlongStep and PostStep
- "-1" means that the process is not active

3 stages

Example G4EmPenelopePhysics

- Process class G4PhotoElectricEffect
- Default model in g4 9.3 is G4PEEffectModel (EM Standard)
- There are alternative Livermore and Penelope models
- Example of the combined EM Physics Lists:

```
G4double limit = 1.0*GeV;

If ( particleName == "gamma" ) {

G4PhotoElectricEffect* pef= new G4PhotoElectricEffect();

G4PenelopePhotoElectricModel* aModel = new

G4PenelopePhotoElectricModel();

aModel->SetHighEnergyLimit(limit);

pef->AddEmModel(0, aModel); // 1<sup>st</sup> parameter - order

pmanager->AddDiscreteProcess(pef);
```

How to extract Physics ?

- Possible to retrieve Physics quantities using a G4EmCalculator object
- Physics List should be initialized
- Example for retrieving the total cross section of a process with name procName: for particle partName and material matName

```
#include "G4EmCalculator.hh"
...
G4EmCalculator emCalculator;
G4Material* material =
   G4NistManager::Instance()->FindOrBuildMaterial("matName);
G4double density = material->GetDensity();
G4double massSigma = emCalculator.ComputeCrossSectionPerVolume
   (energy,particle,procName,material)/density;
G4cout << G4BestUnit(massSigma, "Surface/Mass") << G4endl;</pre>
```

A good example: \$G4INSTALL/examples/extended/electromagnetic/TestEm14 Look in particular at the RunAction.cc class

Let us start exercises of task3a